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Thu, 17 Aug 2006, 5:54:42 PM EST

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| #1 ((mask or reticle<in>metadata) <and> (background <in>metadata) <and> (foreground<in>metadata)) | 71 |
| #2 critical and (feature or image or element or edge) | 134673 |
| #3 ((mask or reticle<in>metadata) <and> (background <in>metadata)) <and> (foreground<in>metadata) <and> (critical and (feature or image or element or edge)) | 13 |
| #4 mr or (magneto and resistive) | 23988 |
| #5 ((mask or reticle<in>metadata) <and> (background <in>metadata)) <and> (foreground <in>metadata) <and> (magneto and resistive)) | 2 |
| #6 mask or reticle | 56014 |
| #7 semiconductor and (mask or reticle) | 19064 |
| #8 (semiconductor and (mask or reticle)) <AND> (mr or (magneto and resistive)) | 534 |
| #9 background and foreground | 3932 |
| #10 ((semiconductor and (mask or reticle)) <AND> (mr or (magneto and resistive))) <AND> (background and foreground) | 12 |